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OTIE LPI102
MAY 12 2006
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THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : FELIX KOLLMER and PETER HOERSTER
Serial No. : 10/568,832
Filed : February 17, 2006
For : MASS SPECTROMETER AND LIQUID-METAL ION
SOURCE FOR A MASS SPECTROMETER OF THIS
TYPE
Customer No. : 010037

May 9, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT

In accordance with 37 CFR §1.56 and §1.97(b), the applicants wish to call the attention of the Examiner to the references listed on the attached Form PTO-1449. Copies of these references are submitted herewith.

U.S. Patent No. 6,002,128

Liquid Metal Gold Cluster Ion Gun for Improved
Molecular Spectroscopy and Imaging, published 2002

The aforementioned references were cited in the "Background of the Invention" section of the present application. Accordingly, no further discussion is believed to be necessary.

U.S. Patent No. 4,686,414

"Cluster Formation Under Bombardment with Polyatomic Projectiles", R. Heinrich, A. Wucher, Elsevier Science B.V., 2000, pp. 720-726.

"Cluster Impacts at keV and MeV Energies: Secondary Emission Phenomena", Yvon Le Beyec, Elsevier Science B.V., 1998, pp. 101-117.

Study of Bi_n^{P+} Ions Formed In Liquid-Metal Ion Sources, Physical Review B, XP-002366516, Vol. 35, No. 11, 15 April 1987, pp. 5509-5513.

"Spike Effects in Heavy-Ion Sputtering of Ag, Au and Pt Thin Films", S.S. Johar and D.A. Thompson, Surface Science XP-002366490 (1979) 319-330.

The aforementioned references were cited in the International Search Report of July 1, 2004 of the corresponding International Application No. PCT/EP2004/007154. A copy of this Report is also enclosed.

Applicant respectfully requests that this prior art be considered during the examination of this application.

No action has issued in the above-identified application therefore, it is respectfully submitted that no fee is due at this time under 37 CFR \$1.97(b).

Respectfully submitted,

By


Karl F. Milde, Jr.

Reg. No. 24,822

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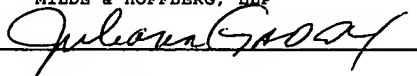
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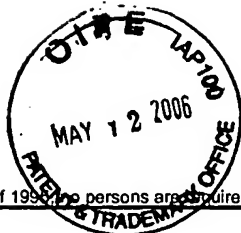
MAY 9, 2006

MILDE & HOFFBERG, LLP

By



Date MAY 9, 2006



Subsidiary Form 1449/PTO

(Use as many sheets as necessary)

Sheet	1	of	2
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Complete if Known

Application Number	10/568,832
Filing Date	FEBRUARY 17, 2006
First Named Inventor	FELIX KOLLMER
Art Unit	
Examiner Name	
Attorney Docket Number	HH 307-KFM

U. S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

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Examiner Signature		Date Considered	
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This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Complete if Known

Sheet	2	of	2	Application Number	10/568,832
				Filing Date	FEBRUARY 17, 2006
				First Named Inventor	FELIX KOLLMER
				Art Unit	
				Examiner Name	
				Attorney Docket Number	HH 307-KFM

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		Liquid Metal Gold Cluster Ion Gun for Improved Molecular Spectroscopy and Imaging, published 2002. ION-TOF GmbH, MUENSTER GERMANY	
		Cluster Formation Under Bombardment with Polyatomic Projectiles, R. Heinrich, A. Wucher, Elsevier Science B.V., 2000, pp. 720-726	
		Cluster Impacts at keV and MeV Energies: Secondary Emission Phenomena, Yvon Le Beyec, Elsevier Science B.V., 1998, pp. 101-117	
		Study of BinP+ Ions Formed In Liquid-Metal Ion Sources, Physical Review B, XP-002366516, Vol. 35, No. 11, 15 April 1987, pp. 5509-5513.	
		Spike Effects in Heavy-Ion Sputtering of Ag, Au and Pt Thin Films", S.S. Johar and D.A. Thompson, Surface Science XP-002366490 (1979) 319-330	

Examiner Signature		Date Considered	
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¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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